10,601,789

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Norio KIMURA et al.

Serial No. NEW

Attn: APPLICATION BRANCH

Filed June 24, 2003

Attorney Docket No. 2003-0865

APPARATUS FOR POLISHING A **SUBSTRATE** (Rule 1.53(b) Divisional of Serial No. 09/897,918, Filed July 5, 2001)

## **CLAIM OF PRIORITY UNDER 35 USC 119**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 203754/2000, filed July 5, 2001, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in parent application Serial No. 09/897,918, filed July 5, 2001.

Respectfully submitted,

Norio KIMURA et al

ACCOUNTING, 2011

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June 24, 2003

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